Western Nanofabrication Facility

Academic Service Work (External) Request For Service Work Provided By Nanofabrication Facility Staff

This form is required for new customers who require work to be performed for them by Nanofabrication Facility Staff. Users who wish to be receive an access card and be trained to perform their own work will instead require the "Academic User (External) Form" Customers who will pay through a UWO speedcode should instead use the "Academic Service Work (Internal)" version of this form.

To create a billing account, **a purchase order must be provided in advance** to cover the anticipated costs. For ongoing work, a standing purchase order is typically used. Please contact nanofab@uwo.ca for cost estimates.

| TT NI | |
|--|---|
| User Name: | |
| Institution: | |
| Department or Unit: | |
| Address: | |
| City and Prov/State | Postal/ZIP Code |
| Telephone : | E-Mail Address: |
| Brief description of service(s) required | l (e.g. SEM, FIB, Deposition, Fabrication, Characterization, etc) |
| Shoe covers, gloves, caps and coats armust sign in and out of the Logbook a | ation Facility to observe - long pants and clean closed toe shoes are required. d safety glasses must be worn at all times in the cleanroom. All users and visitors the entrance. |
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Last Revised: 1/6/2010